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TRANSMITTAL FORM

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		Application Number	09/905,286
		Filing Date	July 13, 2001
		First Named Inventor	Cem Basceri
		Art Unit	1762
		Examiner Name	Fuller, Eric B.
Total Number of Pages in This Submission	9	Attorney Docket Number	MI22-1724

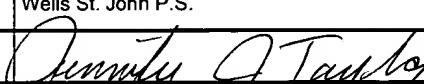
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Certificate

SEP 01 2005

of Correction**SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT**

Firm Name	Wells St. John P.S.		
Signature			
Printed name	Jennifer J. Taylor, Ph.D.		
Date	August 26, 2005	Reg. No.	48,711

CERTIFICATE OF TRANSMISSION/MAILING

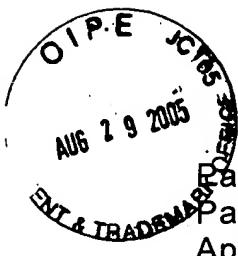
I hereby certify that this correspondence is being facsimile transmitted to the USPTO or deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on the date shown below:

Signature			
Typed or printed name	Jaime M. White	Date	August 26, 2005

This collection of information is required by 37 CFR 1.5. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.11 and 1.14. This collection is estimated to 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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SEP 2 2005



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent No. 6,838,122 B2
Patent Issue Date January 4, 2005
Application Serial No. 09/905,286
Filing Date July 13, 2001
Assignee Micron Technology, Inc.
Inventorship Cem Basceri et al.
Attorney's Docket No. MI22-1724
Title: Chemical Vapor Deposition Methods of Forming Barium Strontium Titanate Comprising Dielectric Layers

**REQUEST FOR CERTIFICATE OF CORRECTION OF PATENT
FOR PTO MISTAKE (37 C.F.R. 1.322(a))**

To: Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

ATTN: Decision and Certificate of Correction
Branch of the Patent Issue Division

From: Jennifer J. Taylor, Ph.D. (Tel. 509-624-4276; Fax 509-838-3424)
Wells St. John P.S.
601 W. First Avenue, Suite 1300
Spokane, WA 99201-3828

Sir:

It is hereby requested that a Certificate of Correction be issued with respect to Patent No. 6,838,122 B2, granted January 4, 2005, in accordance with the Certificate of Correction form attached hereto in duplicate.

The errors listed on the Certificate of Correction form were apparently incurred through the fault of the PTO as will be disclosed by the records of files in the Office.

Since this Certificate of Correction is being requested due to PTO errors, it is believed that no fee is due. However, in the event that a fee is required for issuance of this Certificate of Correction, please charge the fee specified under

37 C.F.R. § 1.20(a) to Deposit Account No. 23-0925. Please credit Deposit Account No. 23-0925 with any overpayment of the above fee.

Attached hereto, in duplicate is Form PTO-1050, with at least one copy being suitable for printing.

Dated:

August 26, 2005

By:

Respectfully submitted,

Jennifer J. Taylor
Jennifer J. Taylor, Ph.D.
Reg. No. 48,711

UNITED STATES PATENT AND TRADEMARK OFFICE
CERTIFICATE OF CORRECTION

PATENT NO. :6,838,122 B2

DATED :January 4, 2005

INVENTOR(S) :Basceri et al.

It is certified that errors appear in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

(56) References cited, Insert --

4,261,698 A	04/1981	Carr et al.
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1 of 3

Mailing Address of Sender:

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Patent No. 6,838,122 B2

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CERTIFICATE OF CORRECTION

PATENT NO. :6,838,122 B2

DATED :January 4, 2005

INVENTOR(S) :Basceri et al.

It is certified that errors appear in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

(56) References cited, Insert --

5,976,990 A	11/1999	Mercaldi et al.
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DATED :January 4, 2005
INVENTOR(S) :Basceri et al.

It is certified that errors appear in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

(56) References cited, Insert --

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